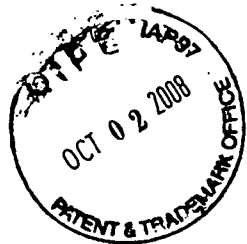


DO NOT ENTER: /A.A./ (10/16/2008)

Attorney Docket No. 63254-0151-US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Li Yao *et al.*

Appln. No.: 10/689,043

Filed: October 21, 2003

For: ABRASIVE-FREE CHEMICAL MECHANICAL POLISHING
COMPOSITION AND POLISHING PROCESS CONTAINING SAME

) Confirmation No. 4499
)
)
) Group Art Unit: 1792
)
) Examiner: ALANKO, A. K.
)
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RESPONSE UNDER 37 C.F.R. §1.116

U.S. Patent and Trademark Office
Randolph Building
401 Dulany Street
Alexandria, Virginia 22314
MAIL STOP – AMENDMENT

Sir:

In response to the Final Office Action mailed on June 16, 2008, the time for responding to which extends up to October 16, 2008, with payment of one month extension fees, please amend the above application as follows:

Amendment to the claims begins on page 2 of this paper; and

Remarks begin on page 6 of this paper.